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PATENT  
Docket No. 20059/PIA31212

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant(s):

Jae Suk Lee

U.S. Serial No.: 10/748,468

For: "Methods for Forming  
Shallow Trench Isolation  
Structures"

Filed: December 30, 2003

Group Art Unit: 2812

Examiner: Not Yet Assigned

) I hereby certify that this paper and the  
documents referred to as enclosed  
therewith are being deposited with the  
United States Postal Service as first  
class mail, postage prepaid, in an  
envelope addressed to Commissioner  
for Patents, P.O. Box 1450,  
Alexandria, Virginia 22313-1450 on  
this date:  
  
February 14, 2005  
  
James A. Flight  
Attorney for Applicant(s)  
Registration No. 37,622

STATUS LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Kindly advise when an Office action can be expected in the above-referenced  
matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC  
USPTO Customer Number 34431  
20 North Wacker Drive  
Suite 4220  
Chicago, Illinois 60606  
(312) 580-1020

By:

James A. Flight  
Registration No.: 37,622

February 14, 2005